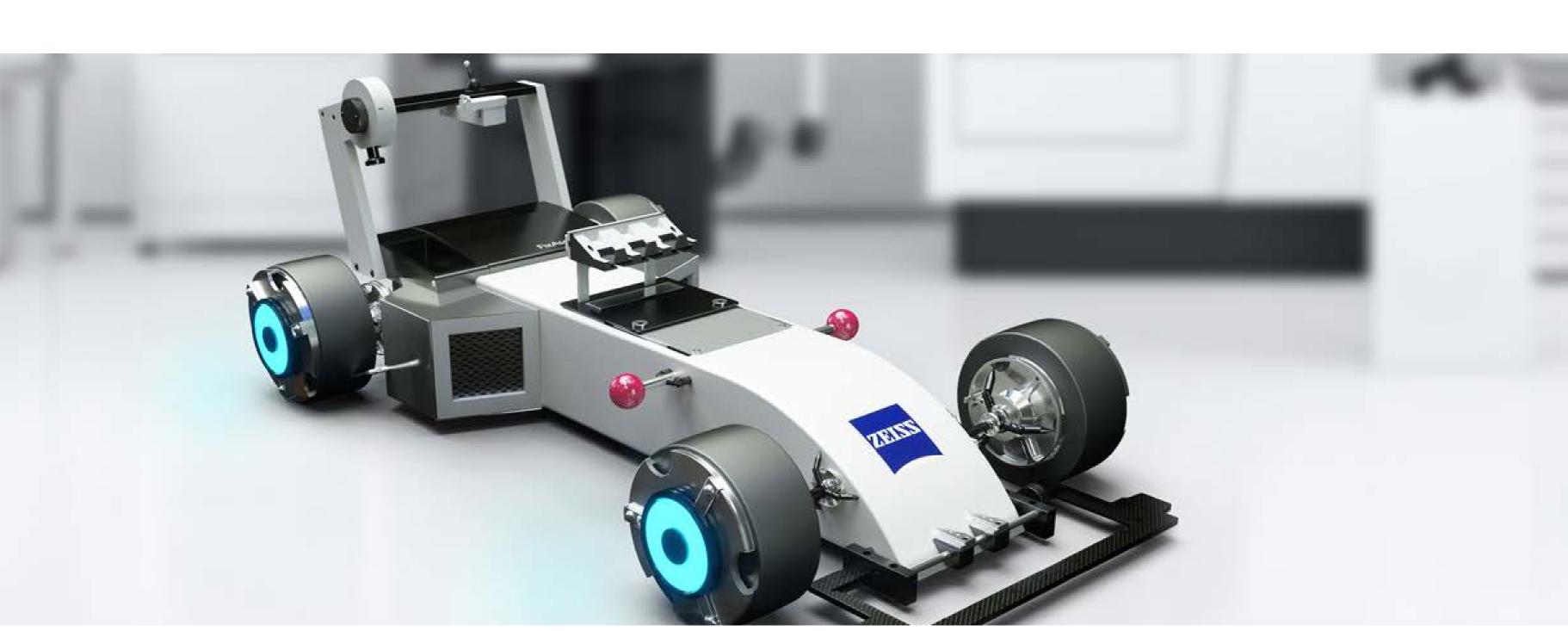


Precision meets Acceleration.

ZEISS O-INSPECT Accessories



Always the right accessories –

for every step of your measuring process

Would you like to increase your productivity without compromising on precision? Our original accessories were developed specifically for the ZEISS O-INSPECT to accelerate your productivity.

Fast and precise preparation







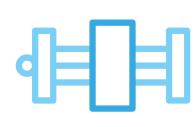
adjustment of stylus

systems.



ZEISS Stylus Assembly Pliers shorten preparation time and simplify assembly.

Fast and efficient set-up





ZEISS OMEGA Pallets increase the productivity of the measuring machine and reduce the set-up time.



ZEISS OmniFix offers an optimal combination of accessibility and flexibility. · ·

Independent accuracy checks





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ZEISS Reference Spheres

results for all available



ensure precise measuring sensors on a regular basis.



ZEISS Calibration Artifacts

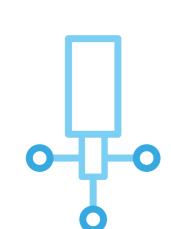
check and ensure the precision of the CMM.



ZEISS Temperature Sensors

record the workpiece temperature to ensure accurate measuring results.

Exact and reliable measurement





ZEISS Stylus Systems

optimized for the VAST XXT probe - enables precision and flexibility. **i**



ZEISS Diffusors

for even light distribution to optimize your measurements. iii iii



ZEISS DotScan

can be used flexibly, even for thickness measurements of transparent surfaces.

Optimal storage





ZEISS Multi Sensor Racks

accelerate measuring processes via automatic stylus system change.



ZEISS ProMax

makes optimal use of the available measuring range and prevents collisions.



ZEISS Multi Sensor Cabinet

organizes parts in the measuring room and protects your stylus systems.



Discover our large selection of original ZEISS accessories – and put your productivity into the fast lane!

